



Session Title:	[ThD2] Alternative Lithography II
Session Date:	November 14 (Thu.), 2024
Session Time:	10:50-11:50
Session Room:	Room D (Sidney Room, 2F, Paradise Hotel Busan)
Session Chair:	Prof. Myung-Ki Kim (Korea Univ., Korea)

[ThD2-1] [Invited]

10:50-11:20

III-V/Si Light Source Integration from on-Demand to Three-Dimensions

You-Shin No (Konkuk Univ., Korea)

[ThD2-2] [Invited]

11:20-11:50

Shadow Growth and Electrostatic Coating for Hybrid Nanoparticles

Jang-Hwan Han, Doeun Kim, and Hyeon-Ho Jeong (GIST, Korea)